

Table of Contents

Surface and Diffusion Barriers to Oxygen Penetration on Simple Metals and their Oxides	1
Phase Stability during Ion Implantation of Metals	13
The Effect of Ion Implantation on the Mechanical Behavior of Metals and Alloys	37
Reply to "the Production of Periodic Surface Features by Sputtering and Related Processes"	55
Reply to Comments on "the Production of Periodic Surface Features by Sputtering and Related Processes"	60
Semiconductors	65
Halides, Oxides, Simple Oxides, Spinel, Garnets, other Complex Oxides, other Ionic Substances, Niobates, Nitrates, Phosphates and Silicates	95
Carbon and Carbides, Sulfides, Miscellaneous and Metals	123
General References, Diffusion Processes, Electromigration, Thermomigration, Point Defects, Linear Defects, Planar Defects, Irradiation Effects and Ionic Conduction	189